

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: SCHAADT ET AL Attorney Docket No.: P117-US
Serial No.: Unknown Group Art Unit:
Filed: 09/17/2003 Examiner:
For: AN ETCHING METHOD IN FABRICATIONS OF MICROSTRUCTURES

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 CFR 1.97(b)

Assistant Commissioner of Patents
Alexandria, VA 22313-1460

September 17, 2003

Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached Form PTO/SB/08A. Copies of the references are enclosed herewith.


The Examiner's attention is also directed to co-pending patent applications:

- a) Methods and Apparatus of Etch Process Control in Fabrications of Microstructures, Shi, et al, filed 9/17/2003, Attorney Docket No. P118-US; and
- b) An Etching Method Used in Fabrications of Microstructures, Shi, et al, filed 9/17/2003, Attorney Docket No. P120-US.

The above information is presented so that the Patent and Trademark Office can determine any materiality thereof to the claimed invention. It is respectfully requested that the information be considered during the prosecution of this application and that the cited documents be listed on the front page of any patent issuing from this application.

The Patent Office is authorized to charge our Deposit Account No. 501516 for any fee it deems to be required to effect consideration of this statement.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Gregory R. Muir", written over a horizontal line.

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